AMENDMENT TO THE CLAIMS

1. (Currently amended) An error portion detecting method for a semiconductor integrated circuit, comprising:

a transition timing detecting step of detecting a transition timing of an input signal input to, or a transition timing of an output signal output from, each of circuit elements which are supplied with a supply voltage through a common power supply line;

a simultaneous-operation circuit element number detecting step of detecting a [[the]] number of circuit elements in which the transition timing of the input signal or output signal occurs within a predetermined time interval; and

a supply voltage variation level estimating step of estimating a supply voltage variation level based on the number of circuit elements which is detected at the simultaneous-operation circuit element number detecting step.

- 2. (Currently amended) The error portion detecting method of claim 1, wherein the supply voltage variation level estimating step includes a [[the]] step of estimating the supply voltage variation level based on a [[the]] variation of the transition timings detected at the transition timing detecting step.
- 3. (Original) The error portion detecting method of claim 1, wherein the circuit elements are transistors.
- 4. (Original) The error portion detecting method of claim 1, wherein the circuit elements are buffer circuits.

5. (Currently amended) The error portion detecting method of claim 1, wherein: the circuit elements are scan flip-flops for testing an [[the]] operation of the semiconductor integrated circuit; and

the input signal is a clock signal which is input to the scan flip-flops.

- 6. (Currently amended) The error portion detecting method of claim 1, wherein the transition timing detecting step includes a [[the]] step of detecting the transition timing of the input signal or output signal by simulating an [[the]] operation of the semiconductor integrated circuit.
- 7. (Currently amended) The error portion detecting method of claim 1, wherein the transition timing detecting step includes a [[the]] step of detecting the transition timing of the input signal or output signal based on a delay time caused by a circuit element and signal line for transmitting the input signal to each of the circuit elements.
- 8. (Currently amended) An error portion detecting method for a semiconductor integrated circuit, comprising:

a circuit element number detecting step of detecting a [[the]] number of circuit elements which are supplied with a supply voltage through a common power supply line and in which input signals are supposed to simultaneously transition when a delay caused by a signal line is neglected; and

a supply voltage variation level estimating step of estimating a supply voltage variation level based on the number detected at the circuit element number detecting step.

9. (Currently amended) A layout method for a semiconductor integrated circuit, comprising:

a transition timing detecting step of detecting a transition timing of an input signal input to, or a transition timing of an output signal output from, each of circuit elements which are supplied with a supply voltage through a common power supply line;

a simultaneous-operation circuit element number detecting step of detecting a [[the]] number of circuit elements in which the transition timing of the input signal or output signal occurs within a predetermined time interval; and

a configuration determining step of determining <u>a</u> [[the]] configuration of the circuit elements or <u>a</u> [[the]] configuration of power supply lines based on the number of circuit elements which is detected at the simultaneous-operation circuit element number detecting step, such that any of the circuit elements is supplied with the supply voltage through a power supply line different from the common power supply line.

10. (Currently amended) A computer-readable medium storing an [[An]] error portion detecting program for a semiconductor integrated circuit which instructs a computer to execute the following steps:

a transition timing detecting step of detecting a transition timing of an input signal input to, or a transition timing of an output signal output from, each of circuit elements which are supplied with a supply voltage through a common power supply line;

a simultaneous-operation circuit element number detecting step of detecting a [[the]] number of circuit elements in which the transition timing of the input signal or output signal occurs within a predetermined time interval; and

a supply voltage variation level estimating step of estimating a supply voltage variation level based on the number of circuit elements which is detected at the simultaneous-operation circuit element number detecting step.

11. (Currently amended) A <u>computer-readable medium storing a layout program for</u> a semiconductor integrated circuit which instructs a computer to execute the following steps:

a transition timing detecting step of detecting a transition timing of an input signal input to, or a transition timing of an output signal output from, each of circuit elements which are supplied with a supply voltage through a common power supply line;

a simultaneous-operation circuit element number detecting step of detecting a [[the]] number of circuit elements in which the transition timing of the input signal or output signal occurs within a predetermined time interval; and

a configuration determining step of determining a [[the]] configuration of the circuit elements or a [[the]] configuration of power supply lines based on the number of circuit elements which is detected at the simultaneous-operation circuit element number detecting step, such that any of the circuit elements is supplied with the supply voltage through a power supply line different from the common power supply line.